



648.42465CX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: YASUI et al

Serial No.: 10/658,398

Filed: September 10, 2003

For: Plasma Processing Apparatus And Plasma
Processing Method

Art Unit: 1765

Examiner: S. Ahmed

AMENDMENT

Mail Stop: Amendment (No Fee)
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

August 17, 2005

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, in response to the Office Action dated May 17, 2005. The amendments are listed below and set forth on the following pages.

Amendments to the Specification;

Amendments to the Claims;

Remarks are included following the amendments.